

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination FULLERTON ET AL.	
		Examiner Holly Rickman	Art Unit 1773	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,408,377	04-1995	Gurney et al.	360/325
*	B	US-5,465,185	11-1995	Heim et al.	360/324.11
*	C	US-5,587,223	12-1996	White, Robert L.	428/195.1
*	D	US-5,768,075	06-1998	Bar-Gadda, Ronny	360/135
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*	F	US-6,280,813	08-2001	Carey et al.	428/828
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	W	Abarra et al., "Longitudinal Magnetic Recording Media with Thermal Stabilization", Program of the 2000 IEEE International Magnetics Conference, 4/9/00-4/13/00, p. AA-06
	X	Toigo, "Avoiding a Data Crunch", Scientific American, 5/2000, pp. 58-61,64-67,70-74

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.